

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: S. KADLEC, et al.  
Serial No.: 10/798,331  
Filed: March 12, 2004  
For: METHOD FOR MANUFACTURING SPUTTER-COATED  
SUBSTRATES, MAGNETRON SOURCE AND SPUTTERING  
CHAMBER WITH SUCH SOURCE  
Group AU: 1795  
Examiner: Michael A. Band  
Confirm. No.: 6134

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

April 28, 2010

Sir:


Pursuant to Applicants' duty of disclosure, enclosed herewith is a copy of the European Search Report, dated April 12, 2010, from the parallel European Patent Application No. EP 09 17 2790. The European Search Report is listed on the attached Form PTO/SB/08A. The references cited in the European Search Report are already of record in the above-identified application as US 6,491,801 and US 2004/020768 A1 [now U.S. 6,837,975] were cited in the Notice of References Cited, PTOL-892, with the Office Action of October 14, 2008. The other three references cited in the European Search Report were previously cited by Applicants in the Information Disclosure Statement filed October 7, 2005. It is noted that all of the references cited in the enclosed European Search Report are cited only in Category A (technological background).

This Information Disclosure Statement is being filed within three months of the date of mailing of the European Search Report and after payment of the issue in the above-identified application on March 29, 2010.

Please charge any shortage of fees due in connection with the filing of this paper to the Deposit Account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (case No. 635.43483X00), or credit any excess fees paid to such Deposit Account.

Respectfully submitted,

**ANTONELLI, TERRY, STOUT & KRAUS, LLP**

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